

Notice of References Cited

Application/Control No.

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Applicant(s)/Patent Under

Reexamination

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Art Unit

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-2004/0114474 a1	06-2004	Park et al.	369/030.05
*	B US-2005/0025007 a1	02-2005	Park, Yong Cheol	369/047.22
C	US-			
D	US-			
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H	US-			
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J	US-			
K	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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